

102657
Venable Filing Number

Atty. Docket No.

32011-165642

Re:

METHOD OF PRODUCING SEMICONDUCTOR DEVICES USING A HYDROGEN PEROXIDE (as amended)

Application No.:

09/639,163

Filing Date:

August 16, 2000

Patent No.:

Issue Date

Trademark:

Trademark Reg. No:

Opposition/Cancellation No:

January 24, 2002

Filing Date


The following items were received from Venable, Washington, D.C., by the U.S. Patent & Trademark Office:

U.S. PTO FEES ENCLOSED

_____	Transmittal Letter	_____	Filing Fee
XX	Submission of Drawings (2 sheets)	_____	Surcharge Fee
_____	Issue Fee Part	_____	Additional Claim Fee
_____	Invention Declaration	_____	Recordation of Assignment Fee
_____	National Stage Application	_____	IDS Fee
_____	Translation of International Application	_____	Extension Fee
_____	New U.S. TM Application (____ specimens)	_____	Notice of Appeal Fee
_____	Rule 53(d) Continuation or Division Application	_____	Brief on Appeal Fee
_____	Rule 53(b) Continuation or Division	_____	Oral Hearing Request Fee
_____	Application (in Duplicate) (attach copy of specifications, claims, drawings & declaration)	_____	Petition Fee
_____	Priority Document-Cert. Copy of _____ Appln. # _____ Date _____	_____	Issue Fee (Additional)
_____	Assignment w/Cover Sheet	_____	Maintenance Fee
_____	IDS w/ PTO-1449 (listing ____ references)	_____	TM Statement of Use
XX	Amendment (with marked up version attached)	_____	8 Affidavit Fee
_____	Submission of Substitute Specification	_____	TM Renewal Application Fee
_____	Petition/Request for Extension of Time	_____	Notice of Opposition Fee
_____	Notice of Appeal	_____	Terminal Disclaimer
_____	Appeal Brief (in triplicate)	_____	Fee: \$0
_____	Request for Oral Hearing	_____	Check Number _____
_____	Confirmation of Hearing Petition		
_____	Letter Under 37 CFR 1.28 (c)		
_____	Certificate of Correction		
_____	Maintenance Fee Transmittal		
_____	TM Statement of Use		
_____	Declaration Under 8		
_____	Declaration Under 8 and 15		
_____	TM renewal Application		
_____	Notice of Opposition		
_____	Supplemental Search Report and Annex		
_____	Postcard		
_____	Change of Address		

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of

Applicants	:	Kaori TAN)	Customer No.
)	
Appln. No.	:	09/639,163)	
)	26694
Filed	:	August 16, 2000)	PATENT TRADEMARK OFFICE
)	
For	:	METHOD OF PRODUCING)	
		SEMICONDUCTOR DEVICES)	
		USING A HYDROGEN PEROXIDE)	
		(as amended))	
)	
Examiner	:	Coleman)	
Art Unit	:	2823		
Atty. Dkt.	:	32011-165642		

AMENDMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

In response to the Office Action of October 24, 2001, please amend this application as follows:

IN THE TITLE:

Please delete the title of the disclosure and replace with the following:

METHOD OF ETCHING SEMICONDUCTOR DEVICES USING A
HYDROGEN PEROXIDE-WATER MIXTURE